Patent Application

National Aeronautics and Space Administration

<u>Headquarters</u> #shington, DC 20546-0001

Washington, DC 20231 .



NPO- 21015-1**2**CU INASA Docket No

Sir:

Transmitted herewith for filing is the Patent Application of:

THE COMMISSIONER OF PATENTS AND TRADEMARKS

Applicant: Jay F. Whitacre, Ratnakumar V. Bugga, William C. West

Inventor(s): Jay F. Whitacre, Ratnakumar V. Bugga, William C. West

Entitled: STRUCTURE AND METHOD FOR MANUFACTURING THIN-FILM LITHIUM MICROBATTERIES

Enclosed are:

Specification, claims, and declaration.

_7 ___ sheets of drawing. X Power of Attorney

An assignment of the invention to the National Aeronautics and Space Administration.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

A license of the invention to the National Aeronautics and Space Administration.

An international application under the PCT. (See PCT/RO/101,XII checklist.)

The fee has been calculated as shown below:

CLAIMS FILED					
FOR	NUMBER		RATE	FEE	
(1)	FILED (2)	EXTRA (3)	(4)	(5)	
TOTAL CLAIMS	20 20	= ;	X :=	=	
INDEPENDENT CLAIMS	з з	= ;	 	=	
BASIC FEE (Minimum amount required) — — — — — — — — — — — — —				\$710.00	
TOTAL FILING FEE				\$710.00	

Please charge our Deposit Account No. 14-0116 in the amount shown as the total filing fee. The Commissioner is hereby authorized to charge an additional fee which may be required to effect the filing of this application under 37 CFR 1.16, or credit any overpayment to Deposit Account No. 14-0116.

John H. Kusmiss

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CERTIFICATE OF MAILING BY "EXPRESS MAIL" UNDER 37 CFR 1.10 - SEPARATE PAPER -

DOCKET NO. NPO- ²¹⁰¹⁵ -1-CU

In Re Application of:

in Ke Application of:				
	Serial Number	r F	iled	
	For structure and me Lithium microbat	ETHOD FOR MANUFACTURIN	G THIN-FILM	
	Group Art Unit	Examiner		
Service "Expre- indicated belo	ify that this paper is being so Mail Post Office to Addresow and is addressed to the An, D.C., 20231.	see" service under 37	CFR 1.10 on the date	
enclosed here	ify that the following were with for filing of the Patent	Application:	lope by me and are	
Information Inform	ttal Letter (Original & 1 copy tion Disclosure Statement (O Form 1449 (pages) and Articles (if applicable)	pages)		
	ation (²⁰ pages including 4 : (1 page), and Drawings (7			
Assignm	tion and Power of Attorney (nent by Inventor to Caltech (ttal Letter (Original	Original) and	,	
Assignm	nent by Caltech to NASA (Or ittal Letter (Original	riginal) and		
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1 Request	and Certification under	35 0.5.0. 1220	7(D)(l)	
	" mailing label number: EK4 sit: February 8, 2001	37904932US		
	John H. Kusi	miss. 32.149		

818-354-7770

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REQUEST AND CERTIFICATION UNDER 35 U.S.C. 122(b)(2)(B)(i)

First Named Inventor				
Title Structure and Method for Manufacturing thin-Film Lithium Microbatteries				
Atty Docket Number	NP0-21015-1-CU			

I hereby certify that the invention disclosed in the attached application has not and will not be the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing. I hereby request that the attached application not be published under 35 U.S.C. 122(b).

February 8, 2001

Date

Signature

John H. Kusmiss

Typed or printed name

This request must be signed in compliance with 37 CFR 1.33(b) and submitted with the application **upon filing**.

Applicant may rescind this nonpublication request at any time. If applicant rescinds a request that an application not be published under 35 U.S.C. 122(b), the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

If applicant subsequently files an application directed to the invention disclosed in the attached application in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing, the applicant **must** notify the United States Patent and Trademark Office of such filing within forty-five (45) days after the date of the filing of such foreign or international application. **Failure to do so will result in abandonment of this application (35 U.S.C. 122(b)(2)(B)(iii)).**

Burden Hour Statement: This collection of information is required by 37 CFR 1.213(a) The information is used by the public to request that an application not be published under 35 U.S.C. 122(b) (and the PTO to process that request). Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14 This form is estimated to take 6 minutes to complete. This time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO Assistant Commissioner for Patents, Washington, DC 20231.